



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LG828681029

Report verification at [igi.org](https://www.igi.org)

August 17, 2026

IGI Report Number

DESCRIPTION

SHAPE AND CUTTING STYLE

MEASUREMENTS

LG828681029

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

7.51 - 7.57 X 4.53 MM

GRADING RESULTS

CARAT WEIGHT

COLOR GRADE

CLARITY GRADE

CUT GRADE

1.59 CARAT

E

VVS 1

IDEAL

ADDITIONAL GRADING INFORMATION

POLISH

SYMMETRY

FLUORESCENCE

INSCRIPTION(S)

EXCELLENT

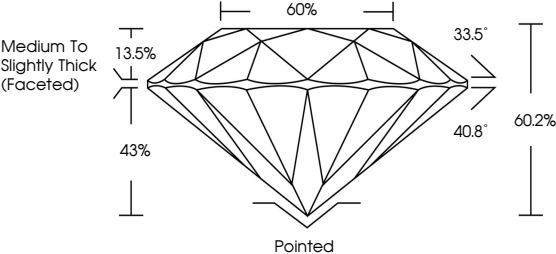
EXCELLENT

NONE

 LG828681029

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)

60%

33.5°

40.8°

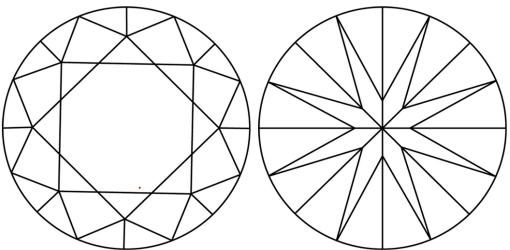
60.2%

43%

13.5%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

CLARITY

D E F G H I J

Faint

Very Light

Light

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



© IGI 2020, International Gemological Institute

FD - 10 20

LABORATORY GROWN DIAMOND REPORT



August 17, 2026

IGI Report Number

DESCRIPTION

SHAPE AND CUTTING STYLE

MEASUREMENTS

LG828681029

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

7.51 - 7.57 X 4.53 MM

GRADING RESULTS

CARAT WEIGHT

COLOR GRADE

CLARITY GRADE

CUT GRADE

1.59 CARAT

E

VVS 1

IDEAL

ADDITIONAL GRADING INFORMATION

POLISH

SYMMETRY

FLUORESCENCE

INSCRIPTION(S)

EXCELLENT

EXCELLENT

NONE

 LG828681029

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



IGI

August 17, 2026

IGI Report No LG828681029

ROUND BRILLIANT

7.51 - 7.57 X 4.53 MM

1.59 CARAT

E

VVS 1

IDEAL

60.2%

60%

Medium To Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

 LG828681029

Cutler

Polish

Symmetry

Fluorescence

Inscriptions(s)

None

None

None

None

None

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa